

PATENT
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VIA FACSIMILE 1-703- 872-9310

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner : George A. Goudreau
 Group : 1763
 Confirmation No. : 4253
 Applicant : Imad Mahawili, PhD
 Serial No. : 09/488,309
 Filed : January 20, 2000
 For : REACTOR WITH REMOTE PLASMA SYSTEM AND
 METHOD OF PROCESSING A SEMICONDUCTOR
 SUBSTRATE

Commissioner for Patents
 Washington, D.C. 20231

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